



Patent
Attorney's Docket No. 018765-177

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of) **MAIL STOP AMENDMENT**
Tsutomu Saimoto et al.)
Application No.: 10/506,806) Group Art Unit: 2811
Filed: September 7, 2004) Examiner: Thomas J. Magee
For: PRESSURE SENSITIVE ADHESIVE) Confirmation No.: 5415
FILM FOR PROTECTION OF)
SEMICONDUCTOR WAFER)
SURFACE AND METHOD OF)
PROTECTING SEMICONDUCTOR)
WAFER WITH THE PRESSURE)
SENSITIVE ADHESIVE FILM)

**AMENDMENT AND SUBMISSION OF VERIFIED TRANSLATION OF
PRIORITY APPLICATION**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed June 2, 2005, please amend the above-identified application as follows: